

**Search Notes**

Application No.

09/894,334

Examiner

W. David Coleman

Applicant(s)

MA ET AL.

Art Unit

2823

**SEARCHED**

Class	Subclass	Date	Examiner
438	52	2/6/2004	WDC

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
EAST 1.4, Applicant claims a process of fabricating a MEMS device which incorporates a sacrificial layer.	2/9/2004	WDC